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## \*\* CONTINUING DATA \*\*\*\*\*

none, of

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2002-81480 12/18/2002 of

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* SMALL ENTITY \*\*

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 5	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
Verified and Acknowledged Examiner's Signature Initials				

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## TITLE

Method of forming a buffer dielectric layer in a semiconductor device and a method of manufacturing a thin film transistor using the same

All Fees

FILING FEE  
RECEIVED  
385

FEES: Authority has been given in Paper  
No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT  
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